

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Priority Application Serial No. 10/051,678
Priority Filing Date January 16, 2002
Inventor Li Li et al.
Assignee Micron Technology, Inc.
Priority Group Art Unit 2824
Priority Examiner Michael Lebentritt
Attorney's Docket No. MI22-2441
Title Processing Method of Forming MRAM Circuitry

PRELIMINARY AMENDMENT

To: Mail Stop Patent Application
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

VIA EXPRESS MAIL

From: Mark S. Matkin(Tel. 509-624-4276; Fax 509-838-3424)
Wells St. John P.S.
601 West First Avenue, Suite 1300
Spokane, WA 99201-3828

Please enter the following amendments prior to examining the above-identified application.

AMENDMENTS

Amendments to the Title

Please amend the title as following:

~~Methods of Forming Integrated Circuitry, Semiconductor Processing~~
Methods, and Processing Method of Forming MRAM Circuitry